

Notice of References Cited	Application/Control No. 10/711,035	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner W. Patty Chen	Art Unit 2871	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0033926	03-2002	Nakahara et al.	349/154
	B	US-			/
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	D	US-			
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FOREIGN PATENT DOCUMENTS

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